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C.C.

Docket No.: M4065.0073/P073
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Donald L. Yates

Application No.: 09/123,430

Art Unit: 2823

Filed: July 28, 1998

Examiner: B. Kebede

For: METHOD OF REDUCING SURFACE
CONTAMINATION IN
SEMICONDUCTOR WET-PROCESSING
VESSELS

SECOND

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Advisory Action dated July 22, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.